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Degradation studies of spray coated polymer films using cantilever sensors

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Micromechanical sensors (cantilevers & strings) are versatile characterization tools for polymers Miniaturized samples allow for fast and precise characterization of polymer degradation processes

Thin polymer layer are placed on cantilevers using a newly

developed spray coating process

The spray coating process have been tested on various polymers - polyvinylpyrrolidone (PVP) and poly (D, L-lactide)

¹Sanjukta Bose; Stephan S. Keller; Tommy Sonne Alstrøm; Anja Boisen & Kristoffer Almdal: Process Optimization of Ultrasonic Spray Coating of Polymer Films. *Langmuit*, **29**, 6911–6919 (2013) Sanjukta Bose; Stephan S. Keller; Anja Boisen & Kristoffer Almdal: Cantilever Sensors as a Tool to Measure Enzymatic Degradation of Poly (D, L-lactide) Coatings. *Polymer Degradation and Stability*, **119**, 1-8 (2015) Sanjukta Bose; Stivan Schmid; Tom Larsen; Stephan S. Keller; Anja Boisen & Kristoffer Almdal: Micromechanical fast quasi-static detection of alpha and beta relaxations with nanograms of polymer. *Journal of Polymer Science*, *Part B: Polymer Physics*, (2015) in press Sanjukta Bose; Stivan Schmid; Tom Larsen; Stephan S. Keller; Fast Sommer-Larsen, Anja Boisen & Kristoffer Almdal: Micromechanical String Resonators: Analytical Tool for Thermal Characterization of Polymers. *ACS Macro Letters*, **3**, 55-58 (2013)

Coating options





PDLLA

one or two cantilevers out of 8 left

Blank cantilevers

Masks available for

Partial coating of cantilevers e.g only coated at tin only coated at the base





9 12 15 18 21 24 27 30 33 36 39 42 0 3 6 Degradation time (hours) Degradation in 50 µg/ml proteinase K, 37°C. Sample removed from solution for each





Prehydration: 3 hours in buffer. 50 µg/ml proteinase K solution degradation





Proteinase K degradation of PDLLA



Optical micrographs; proteinase K, 37°C 10 µg/ml (a-c); 50 µg/ml (d-f). all pictures at same scale. 3 regime indicated in h.

Initial delay is followed by rapid degradation. This is apparently due ater swelling kinetics



enzyme will adsorp to the PDLLA film in relatively short time which allow the degradation to continue after

Getting a uniform sample on the cantilever:





Wet regime - similar to pouring a solution on the substrate:

solvent not sufficiently volatile substrate too cold

spraying nozzle-substrate



The spraying is accomplished using ultrasonic spray coating. The ultra sound driven nozzle produces very

small solution drops

Optimum: enough flow to ensure a continuous film. Insufficient flow to generate capillary flow mediated accumulation of material at the edge



Cantilever theory - 1



Within linear elasticity:

 $EI\frac{\partial^4 U(x,t)}{\partial x^4} + \rho A\frac{\partial^2 U(x,t)}{\partial t^2} = 0$

EI (assumed constant): Young's modulus and I=wh³/12

U(x,t): beam displacement

 λ_n constants representing the eigenfrequencies $\lambda_n = c_n L = 1.875, 4.694, 7.855, \dots; n = 1, 2, 3, \dots$ $k_{\rm eff} = k_{\rm static} \lambda_n^4 / 12 = \lambda_n^4 Ewh^3 / (4 \times 12L^3)$ $m_{\rm eff} = \rho w h L/4$ to give analogy with the harmonic oscillator

For the cantilevers used here (Micromotive GmbH, Octo500D), silicon 100 surface E=170 GPa w=90 um h=5.0±0.3 μm *l*=470 um

Cantilevers theory - 2



A coated cantilever leads to the following modifications:

$$k_{eff} = \sum_{i} \frac{\lambda_n^4 E_i w h_i (z_n - z_i)^2}{48l^3} = \lambda_n^4 \sum_{i} \frac{E_i I_i}{4l^3}$$

The moments of inertia have to be calculated relative to the neutral (zero strain) plane, z_n. For $E_{Si}I_{Si} \gg E_{Pol}I_{Pol}$ the neutral plane does not move and k_{eff} is unchanged compare to the uncoated cantilever Note $E_{si} \ge 50 E_{Pol}$

$$m_{eff} = \frac{Lw}{4} \sum_{i} \rho_i h_i$$

Frequency change dominated by added coating mass



Conclusions

- •An understanding on how to find optimum spray coating conditions for producing uniform micrometer thick films on cantilevers has been established. One needs to be on the borderline between "dry" and "wet" regimes.
- •As long as the flexural stiffness of the polymer coat is small compared to the silicon cantilever, the cantilever eigenfrequency is a measure of mass
- •The degradation process has an induction period which is due to water swelling kinetics and possibly enzyme absorption kinetics on the polymer
- •A versatile platform for fast polymer degradation investigations have been established

Acknowledgements

First eigenmode 1.0 n = 1 0.5 0.0 -0. -1.0 0.6 0.8 02 0.4





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ρ: density; A=wh